

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Appl. No.: 09/921,364
 Applicant: Lucius M. Sherwin
 Filed: 8/2/2001
 Docket No.: TI-30661

Confirmation No. 6223
 TC/A.U.: 2877
 Examiner: Khaled Brown
 Customer No.: 23494

Title: A PARTICLE DETECTION AND REMOVAL APPRATUS FOR USE ON
 WAFER FABRICATION EQUIPMENT TO LOWER TOOL RELATED DEFECTS
 FROM PARTICLE CONTAMINATION

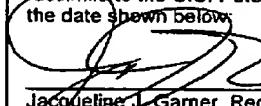
REQUEST FOR EXTENSION OF TIME

Commissioner of Patents
 PO Box 1450
 Alexandria, VA 22313-1450

Dear Sir:

CERTIFICATION OF FACSIMILE TRANSMISSION

I hereby certify that the following papers are being transmitted by
 facsimile to the U.S. Patent and Trademark Office at 703-872-9306 on
 the date shown below:


 Jacqueline J. Garner, Reg. No. 36,144

January 7, 2004
 Date

Pursuant to 37 CFR 1.136(a), Applicant(s) respectfully petitions the Commissioner
 for an extension of the shortened statutory period for response in the above-identified
 Application.

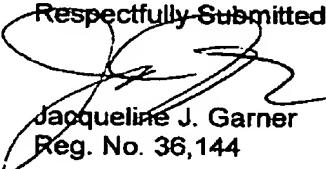
The fee for this extension is indicated below:

- One Month (\$110)
- Two Months (\$420)
- Three Months (\$950)
- Four Months (\$1,480)

Please charge the fee to deposit account no. 20-0668. Any further necessary
 extension of time is hereby requested. Charge any and all fees to deposit account no. 20-
 0668. An original and two copies of this sheet are enclosed.

Texas Instruments Incorporated
 PO Box 655474, M/S 3999
 Dallas, TX 75265
 (214) 532-9348
 Fax: (972) 917-4418

Respectfully Submitted,


 Jacqueline J. Garner
 Reg. No. 36,144